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Bib Data Sheet

CONFIRMATION NO. 6981

SERIAL NUMBER 10/645,065	FILING DATE 08/21/2003 RULE	CLASS 216	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. P/2699-30
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APPLICANTS

Kenichi Yokouchi, Kyoto, JAPAN;
 Takashi Hara, Kyoto, JAPAN;
 Hiroyuki Araki, Kyoto, JAPAN; Nobuyasu Hiraoka, Kyoto, JAPAN;
 Tsuyoshi Okumura, Kyoto, JAPAN;

** CONTINUING DATA *****
none du

** FOREIGN APPLICATIONS *****
 JAPAN 2002-240891 08/21/2002
 JAPAN 2002-283458 09/27/2002
 JAPAN 2002-346179 11/28/2002 *du*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 11/14/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>[Signature]</i> Examiner's Signature	STATE OR COUNTRY JAPAN	SHEETS DRAWING 14	TOTAL CLAIMS 60	INDEPENDENT CLAIMS 9
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Verified and Acknowledged *[Signature]* Initials

ADDRESS
 000002352
 OSTROLENK FABER GERB & SOFFEN
 1180 AVENUE OF THE AMERICAS
 NEW YORK , NY
 100368403

TITLE
 Substrate processing apparatus and substrate processing method

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)